

Contrast Measurement System for Laser Marks

Abstract

This invention relates to a technique of contrast measurement especially useful for the measurement of contrast of laser mark. The technique involves measuring the light intensity coming from a laser mark and the intensity coming from a background on the integrated circuit, calculating the contrast based on the intensities, and comparing to a gray scale. This invention enables contrast to be measured and communicated with respect to a set of references and hence eliminates subjective judgement.

Fig. 5